

Special Issue

Product Design and the Optimization of Technologies for Manufacturing Processes

Message from the Guest Editors

The topics include, but are not limited to:

- The optimization of manufacturing processes and systems and computer-aided design and manufacturing;
- The optimization of technologies and equipment for process industries;
- Optimization in environmental engineering and environmental protection;
- Mechatronics and robotics;
- Economic engineering;
- Chemical and food engineering;
- Computer science and industrial power engineering.

Guest Editors

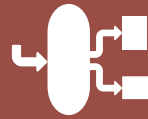
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